Role of Tungsten Doping on the Surface States in BiVO₄

Photoanodes for Water Oxidation: Tuning the Electron Trapping Process

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Supporting Information

ABSTRACT: The nanostructured BiVO₄ photoanodes were prepared by electrospinning and were further characterized by XRD, SEM, and XPS, confirming the bulk and surface modification of the electrodes attained by W addition. The role of surface states (SS) during water oxidation for the as-prepared photoanodes was investigated by using electrochemical, photoelectrochemical, and impedance spectroscopy measurements. An optimum 2% doping is observed in voltammetric measurements with the highest photocurrent density at 1.23 V.REHE under back side illumination. It has been found that a high PEC performance requires an optimum ratio of density of surface states (N SS) with respect to the charge donor density (N D), to give both good conductivity and enough surface reactive sites. The optimum doping (2%) shows the highest N D and SS concentration, which leads to the high film conductivity and reactive sites. The reason for SS acting as reaction sites (i-SS) is suggested to be the reversible redox process of V⁵⁺/V⁴⁺ in semiconductor bulk to form water oxidation intermediates through the electron trapping process. Otherwise, the irreversible surface reductive reaction of VO₂⁺ to VO²⁺ though the electron trapping process raises the surface recombination. W doping does have an effect on the surface properties of the BiVO₄ electrode. It can tune the electron trapping process to obtain a high concentration of i-SS and less surface recombination. This work gives a further understanding for the enhancement of PEC performance caused by W doping in the field of charge transfer at the semiconductor/electrolyte interface.

KEYWORDS: bismuth vanadate, water splitting, photoanode, tungsten doping, surface states

1. INTRODUCTION

Photoelectrochemical (PEC) water splitting to produce clean hydrogen offers a desirable approach to solving global environmental and energy problems. Nonexpensive metal oxide materials such as TiO₂, WO₃, BiVO₄, and Fe₂O₃ have been explored as photoelectrode materials, with inherent stability in aqueous electrolytes, band gap edge alignment that drives force toward water oxidation, and relatively abundant materials. As one of most promising n-type semiconductors, bismuth vanadate with monoclinic structure (ms-BiVO₄) has attracted considerable attention, owing to its good performance for various applications, such as photoelectrochemical water splitting and photocatalytic processes including selective oxidation and organic pollutant degradation under visible light illumination. However, there are three main limitations in the BiVO₄ photoanode: excessive surface recombination, poor charge transport, and sluggish water oxidation kinetics, leading typically to low efficiencies. Doping BiVO₄ is a promising strategy to alleviate its intrinsic limitations. An important number of studies have been devoted to introducing metal atoms (such as Mo and W) to the BiVO₄ lattice in order to improve the water oxidation efficiency. For instance, Mullins et al. synthesized porous, nanostructured BiVO₄ films incorporating Mo and W with a Bi/V/Mo/W atomic ratio of 46:46:6:2 that demonstrated better PEC performance with photocurrent densities 10 times higher than pure BiVO₄. In a similar manner, Bard et al. reported a strategy with W- and Mo-doped BiVO₄ also showing 10 times improvements in the photocurrent values for water oxidation.
In general, the enhancement of PEC performance is attributed to an increase of charge donor density \( N_D \) since dopants substitute V sites and serve as electron donors. According to density functional theory (DFT) calculations, Mo- and W-doping under oxygen-poor growth conditions can produce excellent n-type conductivity.\(^{17}\) In addition, the effect of the dopant on BiVO\(_4\) expresses itself in many ways, including promoting the interfacial and bulk charge separation,\(^{18}\) removing the hole traps in BiVO\(_4\),\(^{19}\) enhancing hole diffusion length,\(^{12}\) creating local electric field,\(^{20}\) decreasing the width of the space charge layer, raising the Fermi level, affecting the morphology, and so on. However, it has been found that an inappropriate doping level would raise many unpredictable issues and lead to a decrease PEC performance. For example, the excessive amount of phosphate dopants may become defect sites in BiVO\(_4\) which act as electron–hole recombination sites,\(^{26}\) and W doping has found to strongly decrease the carrier mobility by introducing intermediate-depth donor defects as carrier traps.\(^{21}\)

It is commonly accepted that surface states (SS) play an important role in photoelectrochemical water oxidation. The SS have been reported to influence charge transfer at the semiconductor/electrolyte interface (SEI) because they can work as reaction sites (i-SS) and/or recombination centers (r-SS) on the electrode surface.\(^{22}\) Previous studies focus on revealing the SS formation on the photoelectrode during the PEC experiment, tuning SS via various modifications, and determining which intermediates might act as SS. Hamann et al. already investigated the SS on hematite photoanodes. They suggested that the hole trapping process into SS is the first step in the water oxidation process, specifically the reversible oxidation of surface hydroxide species, and water oxidation would proceed only after a buildup of the oxidized intermediates.\(^{23}\) In addition, they provided direct evidence of high-valent iron-oxo intermediates as the product of the first hole-transfer reaction on the hematite surface using infrared spectroscopy under PEC water-oxidation conditions.\(^{24}\) CuWO\(_4\) also presents a capacitive feature related to SS as the buildup of water oxidation intermediate species on the surface.\(^{25}\)

Furthermore, it has been reported that the SS can be tuned by various modifications to improve the PEC performance. For example, Monllor-Satoca et al. tuned the SS by optimizing titanium doping level on a hematite photoanode to obtain a good balance between the film conductivity and charge transfer reactive sites, resulting in an isoenergetic hole transfer to water mediated by SS.\(^{5}\) Bottom-up interfacial engineering was reported to tune the SS in hematite multilayer nanowires, which were finely regulated via the atomic addition of an Fe\(_2\)TiO\(_5\) layer and FeNiOOH nanodots.\(^{6}\) Other efforts have been devoted to removing the SS acting as r-SS in hematite; for instance, high temperature treatment (800 °C) and ultrathin Al\(_2\)O\(_3\) coating have been used to selectively remove the r-SS.\(^{26,27}\)

To date, few researchers have reported the presence of SS in BiVO\(_4\) photoanodes. Smith et al. first investigated the formation of highly active water oxidation intermediates and/or changes in the chemistry of the surface of BiVO\(_4\).\(^{9}\) Nevertheless, to the best of our knowledge, research focused on the role of tungsten doping on the SS is almost vacant, despite being widely accepted as an alternative for enhancing the performance of BiVO\(_4\) photoanodes. In this work, we aim to investigate the SS behavior in W-doped BiVO\(_4\) photoanodes for PEC water oxidation and give a further understanding into the PEC enhancement attained by doping.

### 2. EXPERIMENTAL SECTION

#### 2.1. Synthesis of Pristine/W-Doped BiVO\(_4\) Photoanodes by Electrospinning

Nonporous pristine/W-doped BiVO\(_4\) photoanodes were prepared by reported electrospinning technology with some modifications in a Yelow Electrospinning equipment.\(^{12}\) In a typical synthesis procedure, 0.6950 g of bismuth acetate (C\(_{6}\)H\(_{4}\)BiO\(_{3}\)) was added into a mixture of 3 mL of acetic acid, 3.75 mL of absolute ethanol, and 3.75 mL of N,N-dimethylformamide (DMF), as a solvent to form a homogeneous solution, followed by the addition of 0.4772 g of VO(ACAC)\(_3\) and 1.2 g of polyvinylpyrrolidone (PVP, Mw = 1 300 000). Subsequently, the mixture was magnetically stirred at 80 °C for 2 h and then stirred at room temperature overnight. Then, the precursors were transferred into a 20 mL syringe with a stainless steel needle and then were ejected from the needle to a ground aluminum foil vertically placed at 20 cm with a speed of 0.8 mL h\(^{-1}\). The electrospinning proceeded under high voltage (16 kV), and the fibers were collected after 30 min, on previously washed glasses with fluoride doped tin oxide (FTO, 1 × 1 cm\(^2\)) followed by heat treatment. The samples were dried at 80 °C for 1 h and then heated to 500 °C during 1 h with a temperature ramp of 4 °C min\(^{-1}\). The W-doped samples were prepared by adding different amounts of W to replace the equivalent weight of VO(ACAC)\(_3\): the amounts of W precursors (90 μL, 180 and 450 μL) were introduced to reach 1, 2, and 5% atomic substitution of V. The W precursor was prepared by dissolving 0.9994 g of H\(_2\)WO\(_4\) into a mixture of 12 mL of H\(_2\)O and 8 mL of H\(_2\)O.\(_2\)

#### 2.2. Characterization Techniques

**Structure analysis with** X-ray diffraction (XRD) was performed using a Bruker D8 Advance diffractometer equipped with a Cu Ka radiation (0.15417 nm) source, a LYNXEYE super speed detector, and a Ni filter. The morphology of the samples was analyzed using a Zeiss Auriga field emission scanning electron microscope (FESEM). A PHI 5500 Multitechnique model with Al Ka radiation (1486.6 eV) was used to perform X-ray photoelectron spectroscopy (XPS) measurements. Optical properties of all electrodes were recorded in a Lambda 950 UV–vis–NIR spectrometer (PerkinElmer) equipped with a 150 mm integrating sphere coated with Spectralon as a reflectance (white) standard.

#### 2.3. Photoelectrochemical and Electrochemical Measurements

All the photoelectrochemical and electrochemical measurements were conducted in a computer-controlled potentiostat (VMP3, BioLogic Science Instruments) with an undivided three-electrode cell. The counter electrode, reference electrode, and working electrodes were a Pt wire, an Ag/AgCl (3 M KCl) electrode, and the prepared pristine/W-doped BiVO\(_4\) electrodes (1 cm\(^2\) geometric area), respectively. A 0.1 M Na\(_2\)SO\(_4\) solution (pH = 6.8) was used as an electrolyte. Before the experiments, the electrolyte was purged with N\(_2\) for 30 min. Potentials were converted and reported with respect to the reversible hydrogen electrode (RHE): \( E (VS RHE) = E (VS Ag/AgCl) + 0.0592 \times pH + 0.203 \). Measurements under illumination were performed using a 150 W AM 1.5G solar simulator (Solar Light Co., 16S-300-002 v 4.0) with an incident light intensity set at 1 Sun (100 mW cm\(^{-2}\)). The photoelectrochemical impedance spectroscopy (PEIS) measurements were carried out at different applied biases with an alternate light
current (AC) perturbation of 25 mV in amplitude and a frequency range from 100 mHz to 1 MHz, both in the dark and under illumination. The numerical fitting of the impedance data was carried out using the Z-fit (BioLogic Associates) corresponding equivalent circuits.

3. RESULTS AND DISCUSSION

3.1. Characterizations of Pristine/W-Doped BiVO₄ Photoanodes. XRD measurements were performed on pristine and W-doped BiVO₄ photoanodes prepared by electrospinning. As shown in Figure S1, XRD patterns of all photoanodes are consistent with the monoclinic scheelite crystal structure of BiVO₄ (JCPDS 014-0688). There is no evidence of any other impurities except for the additional peaks that can be assigned to the SnO₂ (FTO). However, a slight peak shift can be observed in 2% W-BiVO₄ and 5% W-BiVO₄, as shown in the XRD patterns with a smaller angle range (Figure 1a). The predominant (121) peak at about 28.5° shifts toward the opposite direction of the (040) peak when the W dopant content is higher than 2%, suggesting W is entering into the BiVO₄ lattice. However, the fact of the 1% W-BiVO₄ sample showing no shift may be attributed to the low W doping level. Further, the surface W element composition was characterized by XPS. As can be seen in Figure 1b, two characteristic peaks located at about 35.8 and 38.2 eV arising from W 4f7/2 and W 4f5/2 signals can be observed in the W-doped BiVO₄, suggesting W is in a fully oxidized state (W⁶⁺) to substitute V⁵⁺ atoms on the surface of the BiVO₄ photoanode, and thus, the positive charge will be compensated by free electrons, increasing its conductivity. The peak intensity of W 4f increases by increasing the amount of W dopant. The XRD and XPS results suggest that the bulk and surface of the electrodes have been modified by the addition of W dopant.

Figure 2 shows the morphological characteristics of representative BiVO₄ and W-doped BiVO₄ photoanodes used for PEC measurements. BiVO₄ films are formed of roundish particles with different sizes. Low level incorporation of tungsten (1%) does not change the film morphology (Figure 2a), although slightly smaller feature sizes are observed. However, doping with a higher level of tungsten (2% and 5%)}
3.2. The Effects of W Doping on Photoelectrochemical Performance for Water Splitting. The PEC performances of all photoanodes were measured by using linear sweep voltammetry (LSV) under both back and front side illumination (Figure S3). Results show that the current density at 1.23 V vs RHE ($V_{\text{RHE}}$) increases first and then decreases as the percentage of W is increased. The intermediate W doping (2% W-BiVO$_4$) leads to the highest photocurrent. Consistent with previous studies, back side illumination may give higher values than the front side illumination in materials with low carrier mobility, since the photogenerated electron has to travel shorter distances between the bulk and FTO. Therefore, the slightly larger surface area is present in the W doped BiVO$_4$ electrodes from the observation on SEM (Figure 2). The highly textured surface and porosity would improve hole collection, which is related to the i-SS. As for this, the electrochemically active surface area for each electrode is estimated from the electrochemical double-layer capacitance of the catalytic surface. The detailed calculation is shown in the Supporting Information (Figure S4). It is found that only small improvements happen in the roughness factors after W incorporation, indicating the electrochemically active surface area does not significantly increase. Therefore, the slightly larger surface area of W doped BiVO$_4$ electrodes is suggested not to be the main reason for the enhancement of the PEC performances in this case. W doping yields a positive shift in the onset potential relative to the parent BiVO$_4$ photoanode under back side illumination (up to 100 mV for 2 and 5% W-BiVO$_4$), while no significant changes in the onset potential are observed when illuminating through the front side. To determine the underlying cause for this different behavior, the open-circuit photovoltage ($V_{\text{oc}}$) measurements were carried out under both side illuminations for BiVO$_4$ (Figure 3a). Note that, for the front side illumination, the BiVO$_4$ photoanode shows a short-lived decay of $V_{\text{oc}}$ as soon as the light is on, and an accelerated buildup of $V_{\text{oc}}$ in a short time upon shutting down the light (gray area in Figure 3). The same experiment was performed after the BiVO$_4$ electrode was stabilized in the electrolyte in the dark for 4 h ($V_{\text{oc}}$) was observed as soon as the light is off, and an accelerated buildup of $V_{\text{oc}}$ occurs, indicating the electrochemically active surface area does not alter the band gap of BiVO$_4$. The PEC performance for Water Splitting.
In an effort to find the correlation between W doping treatment and charge transfer behavior, PEIS measurements were performed for the bare BiVO₄ electrode as well as the electrodes modified with W. An equivalent circuit (EC) for impedance modeling requires electric elements for all charge transfer resistances in the bulk and SS at SEI. Consequently, the EC shown in Figure S6a is used to fit the impedance spectroscopy data, which has been adopted extensively for n-type semiconductor photoanodes when SS are present. Nyquist plots resulting from measurements under illumination at 0.7−1.3 VRHE are displayed in Figure S7. It is evident that the fitted results match with the experimental data by comparing the continuous lines and the corresponding markers. Figure 4a shows the charge transfer resistance in bulk (Rₓbulk) associated with charge trapping at surface states as a function of applied potentials. Upon doping the W element into BiVO₄ a lower Rₓbulk is achieved, suggesting that the W doping employed herein improves the charge transfer in the bulk. At the 0.8−1.3 VRHE potential window, the Rₓbulk values of all the electrodes are within the same order of magnitude, and the lowest Rₓbulk appears in the 1% W-BiVO₄ electrode as compared to the 2% and 5% W-BiVO₄ electrodes. As the dopant level is increased, additional imurities might be formed (such as WOₓ), as in the case of the 2 and 5% W-BiVO₄ electrodes. The formation of deleterious BiVO₄−WOₓ heterojunctions (or the increased amount of defects) can also increase the Rₓbulk and give rise to the bulk recombination. Interestingly, capacitance associated with charge accumulation in the bulk (Cbulk) shows a peak at 0.7−1.2 VRHE (Figure 4b). This behavior has been attributed to charge accumulation for the redox process of V⁵⁺/V⁴⁺ in the bulk, as reported by Smith et al. The peak potential clearly moves to more positive values, while the peak intensity decreases by increasing the W content. This is consistent with the reduction peak of V⁵⁺ to V⁴⁺ at the same potential window in the cyclic voltammetry (CV) measurements shown in Figure 4a, indicating that the reductive process of V⁵⁺ to V⁴⁺ in bulk tends to be more difficult with increasing the W doping. Therefore, the order of ease to reduce V⁵⁺ to V⁴⁺ is 5% W-BiVO₄ < 2% W-BiVO₄ < 1% W-BiVO₄ < BiVO₄. According to the DFT calculation by Bard et al., V⁵⁺ is substituted by W⁶⁺, resulting in more V⁴⁺ both in bulk and at the surface, thus suppressing the V⁴⁺ to V⁵⁺ reaction.

Besides the above, it can be observed in Figure 4c that RᵧSS, which is the charge transfer resistance associated with the charge transfer process from surface states, decreases gradually for all the electrodes as the applied potential increases, leading to an increment of associated photocurrent response. The W-doped BiVO₄ electrodes show a remarkable reduction of RᵧSS suggesting W doping does have an effect on the surface properties of BiVO₄ in favor of the charge transfer at SEI. Both 2% and 5% W-BiVO₄ electrodes give similar and fairly low values of RᵧSS for all shown potentials. Notably, the 2% W-BiVO₄ electrode possess a relative minimum RᵧSS at 1.23 VRHE which is about 36-fold lower than that of the pristine BiVO₄ electrode. On the other hand, from Figure 4d, we note that the value of the capacitances of SS (CᵧSS) associated with charge accumulation at SEI, exhibiting a typical Gaussian distribution following an ascending order as BiVO₄ < 2% W-BiVO₄ < 5% W-BiVO₄ < 1% W-BiVO₄ < BiVO₄. According to the formation of intermediates which work as reaction sites on the electrode surface in the PEC water oxidation reaction. A low and a large value of RᵧSS and CᵧSS, respectively, would eventually render larger photocurrents. The LSV results (Figure S3) obtained for the doping level in the 2% W-BiVO₄ electrode agree with its lowest RᵧSS and highest CᵧSS.

Furthermore, a deeper investigation of interfacial charge transfer process is required to highlight the role of SS. First, to ascertain the percentage of charge that is transferred for different electrodes, the charge proportion at SEI can be estimated through eq 1:
Figure 5. $k_{SS}/(k_{bulk} + k_{SS}) = 1/(1 + R_{SS}/R_{bulk})$ (1)

where $k_{bulk}$ and $k_{SS}$ are the charge transfer rate constants in the bulk and SS, respectively. The values of charge transfer resistances are obtained from the fitting PEIS data shown in Figure 4. The resulting ratios as a function of the potential are shown in Figure 5a. The lower the $R_{SS}$ and the larger the $R_{bulk}$ values, the lower the proportion of charge transferred to water at the SEI. Therefore, BiVO$_4$ and 1% W-BiVO$_4$ present the same trend of transfer efficiency and fairly low values of charge transfer ratio in all the applied potentials. It means that few charges would be transferred to the electrolyte with these two electrodes since they suffer significant surface electron–hole recombination. In contrast, the surface recombination in the 2% and 5% W-BiVO$_4$ electrodes has been suppressed leading to remarkable enhancement of charge transfer efficiency, close to 80% at around 1 V$_{RHE}$. Further, the values of the density of states of SS ($N_{SS}$) are derived from the fitted capacitances ($C_{SS}$) as shown in Figure S9. We note that the maximum charge transfer ratio (around 80%) lies in a potential closer to the SS distribution center in line with the statement that the SS can work as reaction sites to provide charge transfer at SEI. The observed tendency is that $N_{SS}$ increases as the percentage of W increases from 0 to 2% and then decreases again at higher percentages, like the photocurrent (Figure S3) and $C_{SS}$ (Figure S4d), but does not fully agree with the charge transfer ratio at higher potentials. For example, the 5% W-BiVO$_4$ electrode presents higher charge transfer efficiency at SEI than 2% W-BiVO$_4$ at the 1.12–1.25 V$_{RHE}$ potential window.

For this reason, the density of donors ($N_{d}$), related to the film conductivity, should be considered. Impedance measurements were performed in the dark to derive the corresponding Mott–Schottky plots. Figure Sb shows a comparison of the total $N_{SS}$, $N_{d}$ and $N_{SS}/N_{d}$ ratio. The detailed calculation of these parameters is shown in the Supporting Information (Figure S10 and Table S1). The 2% W-BiVO$_4$ electrode displays a higher value of $N_{d}$ ($1.12 \times 10^{18}$ cm$^{-3}$) than the pristine BiVO$_4$ ($4.64 \times 10^{17}$ cm$^{-3}$) and 1% W-BiVO$_4$ ($6.00 \times 10^{17}$ cm$^{-3}$) electrodes, since the substitutional W atoms on V sites increase the concentration of majority charge carriers.

However, $N_{d}$ decreases with further increasing the W doping level (5%), perhaps because of the formation of a few dopant impurities (such as WO$_3$), leading to incomplete doping. The total $N_{SS}/N_{d}$ ratios of the four photoanodes follow the order BiVO$_4$ < 1% W-BiVO$_4$ < 5% W-BiVO$_4$ < 2% W-BiVO$_4$. In line with the PEC performance (Figure S3). The 1% W-BiVO$_4$ and BiVO$_4$ electrodes display low $N_{SS}/N_{d}$ ratios attributed to presenting a low concentration of $N_{d}$ which is not high enough to provide good film conductivity; then the fast bulk/surface recombination results in low $N_{SS}$. The 5% W-BiVO$_4$ sample shows a remarkable higher total $N_{SS}/N_{d}$ ratio in comparison with 1% W-BiVO$_4$ mainly because of its high $N_{SS}$ concentration, suggesting that the SS increasing can improve the PEC performance. Notably, the total $N_{SS}/N_{d}$ ratio of 2% W-BiVO$_4$ is similar to that of 5% W-BiVO$_4$ in agreement with their charge transfer behaviors (Figure 5a). However, 2% W-BiVO$_4$ also exhibits the maximum values in total $N_{SS}$ and $N_{d}$. It has been suggested that a high PEC performance requires not only a large $N_{SS}/N_{d}$ ratio but also numerous total $N_{SS}$ and $N_{d}$ to give both good conductivity and enough surface reactive sites.

3.3. Electron Trapping Process for Surface Charge Transfer Site (i-SS). To further understand the charge transfer at the SEI, we performed CV measurements with the BiVO$_4$ electrode in the dark and under illumination (Figure 6). A pair of reversible anodic and cathodic peaks at about 0.87 V$_{RHE}$ in the dark can be noted, which correspond to the reduction of the V$^{5+}$/V$^{4+}$ redox system in the BiVO$_4$ bulk (according to eqs 2 and 3). A simplified scheme can be found in Figure S11.

$$V^{5+} + e^{-} = V^{4+}$$

(2)

$$V^{5+} + H^+ + e^{-} = V^{4+} + H_2$$

(3)

It is noteworthy that this redox process is significantly enhanced under illumination. In order to get a better understanding, CV measurements at various scan rates ($v$) in the dark and under illumination were carried out (Figure 7). A
A good liner relationship is observed between the oxidative peak current density and \( v \) in the dark (Figure 7a and b), suggesting that the reversible redox process of \( V^{4+}/V^{5+} \) in BiVO\(_4\) is a surface catalytic reaction in the dark, which means that the reaction rate depends on the number of the active sites (\( V^{4+} \) and \( V^{5+} \)). A similar behavior is observed in the W-doped BiVO\(_4\) electrodes (Figure S12). However, under illumination, the CV curves of BiVO\(_4\) show good linear correlation between the oxidative peak current density and \( v^{1/2} \) (Figure 7c and d), implying that the reaction turns into a diffusion control reaction. The origin of this situation can be that a great amount of reactive sites (\( V^{4+} \) and \( V^{5+} \)) are produced benefitting from photogenerated electrons. We attribute this to a photoelectron trapping/detrapping process (eqs 4 and 5).

\[
\text{Trapping: } V^{5+}\text{(bulk)} + H^{+}\text{(aq)} + e_{\text{photo}} \rightarrow V^{4+}\text{(bulk)} + H^+\text{(bulk)} \tag{4}
\]

\[
\text{Detrapping: } V^{4+}\text{(bulk)} + H^{+}\text{(bulk)} \rightarrow V^{5+}\text{(bulk)} + H^+\text{(aq)} + e_{\text{photo}} \tag{5}
\]

Importantly, the intrinsic reversible behavior observed in the cathodic and anodic directions implies that the trapping and detrapping are fast, so that the traps are not going to act as recombination centers. In contrast, the presence of intermediate \( V^{4+} \) formed by the trapping process (eq 4) can induce oxygen vacancies (\( V_o \)) on the surface of nano-particles. Some negative charged species tend to be adsorbed on the electrode surface by positive charged \( V_o \). According to the first-principles calculations by Hu et al., when \( V_o \)'s are present on the surface, the adsorption energies of \( H_{2}O_{ads}, OH_{ads} \) and \( O_{ads} \) are higher, implying enhanced hole transfer from the photoanode surface to the electrolyte. We attribute i-SS to the formation of \( V_o \) by the electron trapping process (eq 4) to adsorb oxy/hydroxyl species on the surface of BiVO\(_4\) similar to the report by Smith et al. A model is proposed to illustrate the electron trapping/detrapping process under illumination with a formation of i-SS, as shown in Figure S13. The hole can be trapped by \( V_o \) and transferred to the electrolyte, as shown in eq 6 and illustrated in Figure S14.

\[
V^{4+}(h_{\text{trap}})\cdots OH^- \rightarrow V^{4+} + OH^* \tag{6}
\]

3.4. Electron Trapping Process for Surface Recombination (r-SS). Figure 8 shows CV curves of BiVO\(_4\) in a larger potential range. The resulting curves in the dark and under illumination conditions with a 2000 mV s\(^{-1}\) scan rate.
illumination clearly display two cathodic peaks. The cathodic peak at around 1 VRHE corresponds to the electron trapping process for the reduction of V⁵⁺ to V⁴⁺ in the bulk as discussed above. The cathodic peak at around 1.55 VRHE in the dark agrees with the intrinsic surface reaction of VO₂⁺/VO₂⁺, corresponding to the reductive reaction in eq 7.66 Similar to the redox process of V⁴⁺/V⁵⁺ in the bulk, the surface reaction of VO₂⁺/VO₂⁺ is also significantly favored under illumination, which can be attributed to another photoelectron trapping process (eq 8).

\[
\text{VO}_2^+(\text{surface}) + 2\text{H}^+(\text{aq}) + e^-_{\text{inject}} \rightarrow \text{VO}_2^+(\text{surface}) + \text{H}_2 \quad (7)
\]

Trapping: \[
\text{VO}_2^+(\text{surface}) + 2\text{H}^+(\text{aq}) + e^-_{\text{photo}} \rightarrow \text{VO}_2^+(\text{surface}) + \text{H}_2 \quad (8)
\]

As a consequence, we attribute r-SS to the formation of trap states by the electron trapping process (eq 8) on the surface. Although the peak maximum potential is higher than the water oxidation potential (1.23 VRHE), the potential range of this state covers the water oxidation during illumination (Figure 8). Therefore, one of the main causes of the low PEC performance for the BiVO₄ electrode might be the presence of r-SS.

3.5. Improvement of i-SS and Passivation of r-SS by W Doping. The previous observations indicate that i-SS and r-SS are attributed to the reduction of V⁵⁺ species in the bulk and on the surface, respectively, under illumination. Reasonably, it is important to observe the reductive behavior of V⁵⁺ species on the pristine/W-doped BiVO₄ electrodes to determine the effect of W-doping on the i-SS and r-SS. A typical CV measurement reported by Hamann et al. was carried out in the dark for the pristine/W-doped BiVO₄ electrodes (Figure 9).23 For this purpose, the electrodes were held at 2 V vs Ag/AgCl (VAg/AgCl) for 120 s to fully oxidize the SS23,24,26 The following cathodic scan in the dark shows cathodic peaks corresponding to the reduction of SS, which is equivalent to recombination of surface trapped holes with conduction band electrons.25 The resulting curves clearly display two cathodic peaks at around 1.0 VRHE (peak 1) and 1.55 VRHE (peak 2) in the first cycle. These peaks decrease significantly in the second cycle due to the transient nature of the oxidized states.25,26 On the other hand, peak 1 is consistent with the electron trapping process for the reduction of V⁵⁺ to V⁴⁺ in bulk. This is equivalent to filling the i-SS, which is associated with water oxidation according to the above description. The reversible redox process of V⁴⁺/V⁵⁺ can be observed both under dark and illumination conditions, indicating they belong to intrinsic surface states.21 The chopped LSVs for all electrodes in Figure S16 show negative current transients only in the low applied

\[
\text{VO}_2^+(\text{surface}) + 2\text{H}^+(\text{aq}) \xrightleftharpoons[\text{h}_{\text{TRAP}}]^{\text{e}_{\text{TRAP}} + \text{h}_{\text{TRAP}}} \text{VO}_2^+(\text{surface}) \quad (9)
\]
potential region (about 0.6−0.8 VRHE). These current transients observed upon turning the light off represent the accumulated holes reacting with free electrons in the conduction band.47 No negative current transients at higher potential can be explained by the fact that i-SS is activated, promoting charge transfer at SEI, similar to the IrOx catalyst for the hematite electrode.31 On the other hand, peak 2 corresponds to the electron trapping process for the surface reductive reaction of VO2+ to VO2, which is assigned to r-SS. In fact, this reaction is intrinsic in the BiVO4 electrode as well as the reduction of V5+ to V4+ in the bulk, since the cathodic peaks are present in all cycles of the CV.

As can be seen, the peak 2 intensity clearly decreases with increasing the content of the W dopant, and the potentials shift to a more anodic potential (Figure 9). According to the area of peak 2, it can be inferred that the concentrations of r-SS for the photoanodes follow the order 5% W-BiVO4 < 2% W-BiVO4 < 1% W-BiVO4 < BiVO4 electrodes. BiVO4 and 1% W-BiVO4 suffer a huge number of surface recombinations, thereby lowering PEC performance (Figure S3). Interestingly, peak 1 is high in BiVO4 and 1% W-BiVO4, suggesting they also present high concentrations of i-SS after the pretreatment to fully oxidize the SS. This is in agreement with the surface recombination limitation of BiVO4 reported by van der Krol et al., rather than the charge transfer.38 The reason why BiVO4 and 1% W-BiVO4 show low SS (in Figure 5b) without fully oxidized SS is that most of photogenerated electrons are trapped for r-SS so that there are less for i-SS. Therefore, BiVO4 and 1% W-BiVO4 present low charge transfer efficiency at i-SS (Figure 5a). The r-SS is passivated remarkably in 2% and 5% W-BiVO4 electrodes. The intensity of peak 1 for 5% W-BiVO4 is significantly lower than that of 2% W-BiVO4. Clearly, 2% W-BiVO4 shows slightly higher r-SS than 5% W-BiVO4, but 2% W-BiVO4 has a quite larger i-SS than 5% W-BiVO4, in line with the results in Figure 5b. This suggests that the PEC performance mainly depends on i-SS related to the bulk properties when the surface recombination is suppressed. The Bode plots analysis can further support this suggestion. Figure S17 displays the Bode plots for all photoanodes at three selected potentials (0.7, 1.0, and 1.3 VRHE) under illumination.39 The higher the phase value, the more capacitive is the behavior of the system, reflecting the accumulation of charge at a certain interface.38 The low frequency peak at around 200 mHz is related to the capacitance at SEI. It disappears in 2% and 5% W-BiVO4 at 1.0 and 1.3 VRHE, suggesting the charge transfer at SEI is fast and the PEC water oxidation is limited mainly by the intrinsic properties of the semiconductor bulk.38 The electron−hole recombination processes are further studied by the photocurrent−time transient measurements at 1.23 VRHE (Figure 10). The steady state photocurrent reached after a certain period of illumination (jss) of all electrodes follows the order BiVO4 < 1% W-BiVO4 < 5% W-BiVO4 < 2% W-BiVO4 in line with the LSV measurements. Figure 10b shows the ratio jss/j0, obtained from Figure 10a. This ratio jss/j0 can be explained in terms of electron back reaction that is superimposed to the anodic photocurrent.3 For the back reaction, it can be considered that the electrons promoted to the conduction band from the valence band are (1) recombined with hole in bulk and (2) trapped at surface states at SEI and
The pristine BiVO₄ and 1% W-BiVO₄ show low values of \( j_{ss}/j_0 \), implying they suffer a fast electron back reaction. The ratio of \( j_{ss}/j_0 \) reaches its maximum at a 2% W doping level but decreases at a 5% W doping level. The electron back reaction for surface recombination in 5% W-BiVO₄ is very slow due to its low concentration of r-SS. However, the lower \( N_d \) of 5% W-BiVO₄ would result in a fast electron back reaction for recombination in bulk. It can be further confirmed that the bulk properties would dominate the PEC performance when the surface recombination is suppressed.

On the basis of the above discussion, a model is depicted in Figure 11 to illustrate the proposed mechanism as a function of the W doping level (low, middle, and high). Upon illumination, a photoelectron trapping process can be generated in two ways: trapping for the reversible redox process of V⁵⁺/V⁴⁺ in semiconductor bulk and irreversible surface reduction of VO₂⁺ to VO₂⁺ on the surface. The former does not raise recombination benefitting from its fast detrapping process, and the intermediate V⁴⁺ can introduce Vₐ which can adsorb oxy/hydroxyl species on the surface, forming i-SS. Otherwise, the latter produces r-SS due to the slow detrapping process. Meanwhile, substitution of V⁵⁺ by W⁶⁺ can produce more V⁴⁺ and increase the \( N_d \) for the host lattice, resulting in a suppression of the electron bulk and surface trapping.

For a low W doping level (Figure 11a), due to the low \( N_d \), the charge separation is not efficient, and back-reaction processes are fast for the photogenerated electron created close to the surface. Thus, the electron is easily trapped by VO₂⁺, generating a large concentration of r-SS that results in a fast hole transfer for surface recombination. As a consequence, the hole transfer to i-SS for water oxidation is slow, leading to low PEC performance. At a middle W doping level (Figure 11b), with higher film conductivity and more substitutional W atoms on the surface, the surface electron trapping process is suppressed so that the r-SS is passivated. Therefore, the electron trapping process in the bulk is favored, producing a high concentration of i-SS, which improves the hole transfer for water oxidation. Finally, for a higher W doping level (Figure 11c), not only surface reactive reaction of VO₂⁺/VO₂⁺ but also the redox process of V⁵⁺/V⁴⁺ in the bulk are weakened, so there are no r-SS’s and a low concentration of i-SS. The proposed mechanism can be further confirmed by XPS analysis. Figure 12 shows the high-resolution XPS spectra in the O 1s region for all photoanodes. The peak can be assigned to surface lattice oxygen (V−O) at around 530 eV and surface adsorbed oxygen (−OH) at around 532 eV. The peak area ratios of −OH/V−O in BiVO₄ and 1% W-BiVO₄ are 34.5 and 32.9%, respectively. The ratio increases to 54.2% in 2% W-BiVO₄ and then decreases again in 5% W-BiVO₄ (42.4%). The enhancement of −OH presence reflects an increased concentration of surface Vₐ, implying a high amount of i-SS. The change trend in −OH species concentration is in agreement with the i-SS behavior in the electrodes with increasing W doping level.

**CONCLUSIONS**

The i-SS and r-SS are observed on the pristine and W-doped BiVO₄ photoanodes fabricated by electrospinning for PEC water oxidation. The reversible redox process of V⁵⁺/V⁴⁺ in bulk can induce Vₐ by an electron trapping process, which can adsorb oxy/hydroxyl species on the surface to form i-SS, while the irreversible surface reaction of VO₂⁺/VO₂⁺ generated at higher potential can trap the photogenerated electron to form r-SS. W-doping is confirmed to modify the bulk and surface properties of the BiVO₄ electrode by suppressing the electron trapping processes in bulk and on the surface. The optimum intermediate W-doping level (2%) is suggested to remove the r-SS but preserve the i-SS. As a result of that, 2% W-BiVO₄ shows a remarkable photocurrent increase with respect to the pristine BiVO₄ at 1.23 V_RHE, in line with impedance measurements that...
show the lowest total charge transfer resistance and the highest concentration of i-SS. It is suggested that a high PEC performance requires not only a large total \( N_{SS}/N_d \) ratio but also numerous total \( N_{SS} \) and \( N_d \) to give both good conductivity and enough surface reactive sites. This paper provides a further understanding of the fundamentals for the enhancement of PEC performance and would help to design photoanodes for solar-driven water oxidation or wastewater treatment.

**ASSOCIATED CONTENT**

- Supporting Information
  - The Supporting Information is available free of charge on the ACS Publications website at DOI: 10.1021/acscatal.7b04277.
  - XRD data, UV−vis, LSV data, equivalent circuits, additional CV curves, Nyquist plots, data of \( N_{SS} \) and \( N_d \), Mott−Schottky plots, Bode plots, double-layer capacitance, and schemes to illustrate mechanism related to the SS (PDF)

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